



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6540**
Minoru NAKANO : Attorney Docket No. 2002-0046A
Serial No. 10/050,101 : Group Art Unit 2193
Filed January 18, 2002 : Examiner John Q. Chavis
SYSTEM FOR SUPPLYING : **MAIL STOP: RCE**
SEMICONDUCTOR MANUFACTURING
SYSTEM CONTROL PROGRAMS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 27, 2006, the period for response to which having been extended by three months to September 27, 2006, kindly amend the above-referenced U.S. patent application as follows: